



**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
Form PTO-1449 (Modified)
(Use several sheets if necessary)

COMPLETE IF KNOWN

Application Number	10/606,992
Confirmation Number	
Filing Date	June 25, 2003
First Named Inventor	Dan Daeweon Cheong
Group Art Unit	
Examiner Name	
Attorney Docket No.	356828001US1

Sheet 1 of 1

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	U.S. Patent or Application		Name of Patentee or Inventor of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		NUMBER	Kind Code (if known)			
TAM		4,242,370		Abdalla Mohamed I et al.	12/30/80	
TAM		5,043,614		Yockey	9/27/91	
TAM		5,372,837		Shimoyama et al.	12/13/94	
TAM		5,432,015		Wu et al.	7/11/95	
TAM		5,505,986		Velthaus et al.	4/9/96	
TAM		5,865,887		Wijaranakula et al.	2/2/99	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Foreign Patent or Application			Name of Patentee or Applicant of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T
		Office	NUMBER	Kind Code (if known)				
TAM		EP	0 720 418		GTE Products Corporation	5/8/85		
TAM		EP	0 740 490	A1	Nippon Hosokai	7/3/96		
TAM		JP	61292894		Mitsui Mining & Smelting Co., Ltd.	10/30/96		
TAM		JP	63259067		Fujitsu Ltd.	12/23/86		
TAM		JP	2306591		Nippon Sheet Glass Co. Ltd.	10/26/88		
TAM		JP	7263144		Hitachi Chem. Co. Ltd.	12/19/90		
TAM		JP	11061386		Chisso Corporation	10/13/95		
TAM		JP	1065762		Fuji Electric Co. Ltd.	1/30/01		
TAM		GB	1 469 230		Associated Electrical Industries Ltd.	4/19/67		
TAM		GB	1 469 230		Megson et al.	4/6/77		

OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume issue number(s), publisher, city and/or country where published.	T
		PATENT ABSTRACTS OF JAPAN, Vol. 013, No. 069 (C-569), 16 February 1989, Abstract of Application No. 62091399.	
TAM		Eguchi, K., et al., "Composition Self-Matching Phenomena in Chemical Vapor Deposition of Thin Films," Electrochemical Society Proceedings, Vol. 98-3, p.179-189.	
TAM		Kawahara T., et al., "Step Coverage and Electrical Properties of Films Prepared," Electrochemical Society Proceedings, Vol. 98-3, p.190-195.	

EXAMINER	DATE CONSIDERED 12/21/04
*EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application(s).	